

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Chang, *et al.*

Attorney Docket: TSM02-0658

Filed: Herewith

Examiner: TBD

Serial No.: TBD

Art Unit: TBD

For: Holographic Reticle and Patterning Method

Mail Stop: Patent Application
Commissioner for Patents
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Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

The Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form SB-08A that may be considered material to the examination of the above-identified application.

No fee is due at this time, as this Information Disclosure Statement is being filed concurrently with the patent application.

Respectfully submitted,



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March 3, 2004

Date

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Complete if Known	
				Application Number	TBD
				Filing Date	Herewith
				First Named Inventor	Chang, <i>et al.</i>
				Art Unit	TBD
				Examiner Name	TBD
Sheet	1	of	1	Attorney Docket Number	TSM02-0658

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
	A	US-3,677,634	07-18-1972	Mathisen	
	B	US-3,712,813	01-23-1973	Ross, <i>et al.</i>	
	C	US-4,734,345	03-29-1988	Nomura, <i>et al.</i>	
	D	US-4,857,425	08-15-1989	Phillips	
	E	US-4,966,428	10-30-1990	Phillips	
	F	US-5,187,372	02-16-1993	Clube	
	G	US-5,504,596	04-02-1996	Goto, <i>et al.</i>	
	H	US-5,528,390	06-18-1996	Goto, <i>et al.</i>	
	I	US-5,774,240	06-30-1998	Goto, <i>et al.</i>	
		US-			
		US-			
		US-			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
	J	DT-1 331 076	09-19-1973	SIEMENS		

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	K	WOLF, STANLEY, Ph.D. and TAUBER, RICHARD N., Ph.D.; Silicon Processing for the VLSI Era, 2000; pp. 615-635; Volume 1: Process Technology Second Edition; Lattice Press, Sunset Beach, California.	
	L	MÜTZEL, MARIO; "Building 3D Nanostructures with Holograms"; STP-Gateway; April 3, 2002; http://www.stp-gateway.de/Archiv/archiv475-e.html	
	M	MARDER, SETH, <i>et al.</i> ; "Materials Absorb Two Photons, Generate Acid on Cue"; UniSci Daily University Science News; May 13, 2002; http://unisci.com/stories/20022/0513023.htm	
	N	STILES, LORI; "Cornell Researchers Collaborate on a Major Advance in Microfabrication"; Cornell Chronicle; May 16, 2002; http://www.news.cornell.edu/Chronicle/02/5.16.02/Ober-3D_fab.html	

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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